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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

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MAY 21 2003  
TC 1700

IN RE APPLICATION OF:

TSUTOMU HIROKI

:

: EXAMINER: MOORE, KARLA A.

SERIAL NO: 09/655,304

:

FILED: SEPTEMBER 5, 2000

: GROUP ART UNIT: 1763

FOR: TRANSFER APPARATUS AND :  
ACCOMMODATING APPARATUS  
FOR SEMICONDUCTOR PROCESS,  
AND SEMICONDUCTOR  
PROCESSING SYSTEM

#7A  
5/22/03  
MW

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

In response to the Official Action dated January 17, 2003, please amend the above-identified application as follows:

IN THE CLAIMS

Please amend the claims as shown in the marked-up copy.<sup>1</sup>

1. (Amended) A transfer apparatus for a semiconductor process, comprising:

A<sub>1</sub> an articulated arm unit attached to a support base to be stretchable/retractable within a horizontal plane, the articulated arm unit having a distal end arm which reciprocates in a first direction when the articulated arm unit stretches and retracts;

<sup>1</sup>The marked-up copy attached herewith shows using underlining and bracketing the changes made in the claims.